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an Open Access Journal by MDPI

Recent Advances in Inkjet Technology

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Deadline for manuscript
submissions:

closed (31 March 2022)

Message from the Guest Editor

Dear colleagues,

Inkjet is a well-established technology that has been applied in various applications ranging from graphical printing to functional material printing. Inkjet has many advantages over traditional manufacturing technology such as being a simple process and allowing reduction of waste materials and scalability. Since it was first developed some time ago, much foundational research in this area has already been completed, though it is attracting attention again thanks to the recent trend of applying this technology in the display industry. Inkjet is actually a collection of technologies in design, fabrication, operation, and ink manufacturing and applications, and there are many unresolved problems in each of the many areas. Inkjet can be successfully applied to even more fields only when unsolved problems are resolved through the active participation of numerous researchers. We invite you to submit your research results related to inkjet technology for this Special Issue.



mdpi.com/si/65601

Special Issue



Editor-in-Chief

Message from the Editor-in-Chief

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